

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Takeshi HAMADA et al

Serial No.: 10/051,064

Filed: January 18, 2002

Art Unit: 2823

Examiner: F. Toledo

For: SEMICONDUCTOR DEVICE AND METHOD  
OF MANUFACTURING THE SAME

**RECEIVED**

MAR 31 2004

OFFICE OF PETITIONS

**CERTIFICATE OF TRANSMISSION**

I hereby certify that this correspondence is being sent  
by facsimile to the Commissioner for Patents

Date March 29 2004

Fax Number (703) 308 - 6916

Shannon Wallace  
Print or Type Name of Person

Signature Shannon Wallace

**SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 C.F.R. §1.97, as revised on February 4, 1992,  
1135 OG 23-24, Applicant hereby calls the Examiner's attention to  
documents listed on the attached form, which documents may be  
material to the examination of this application. Copies of the  
references are enclosed herewith for the Examiner's consideration.

The family of US Patent 6,420,758 B1 cited herein includes:  
US Patent Application Publication no. US 2002/0142554 A1

The family of US Patent 6,576,926 B1 cited herein includes:  
US Patent Application Publication no. US 2003/0197179 A1

The family of US Patent 6,306,694 B1 cited herein includes:  
US Patent Application Publication no. US 2002/0028543 A1

The family of US Patent 6,531,713 B1 cited herein includes:  
US Patent Application Publication no. US 2003/0062499 A1

Date: March 29, 2004

The family of US Patent 6,531,713 B1 cited herein includes:  
US Patent Application Publication no. US 2003/0062499 A1

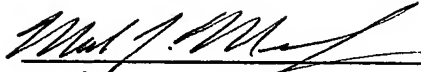
No inference should be drawn that the attached list sets forth a comprehensive investigation of the prior art, that any or all are pertinent to the invention, or that any apparatus disclosed is equivalent to the subject invention.

The citation of the above-discussed documents is not to be construed as an assertion that more pertinent art could not possibly be in existence. Citation of any document herein is not to be construed as an admission that any subject matter disclosed in the document is necessarily within the inventive field of endeavor, that any disclosure is necessarily prior in time to a particular date which may be relevant to the instant patent application, and/or that any disclosure is otherwise necessarily prior art with respect to the instant invention.

Applicant also respectfully reserves the right to later set forth how the instant invention is distinguished over the disclosure of any document or other art, including the disclosure of those documents discussed herein, that may be cited by the Examiner in rejecting a claim in the instant patent application.

As a RCE is being filed herewith no fee is believed necessary. If a fee is required, please charge Deposit Account No. 50/1039.

Respectfully submitted,



Mark J. Murphy

Registration No: 34,225

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LIST OF PUBLICATIONS CITED BY APPLICANT	Atty. Docket No. SEL 299	Serial No. 10/051,064
	Applicant Takashi HAMADA et al	<b>RECEIVED</b>  MAR 3 1 2004
	Filing Date January 18, 2002	Group 2823 <b>OFFICE OF PETITIONS</b>

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB- CLASS	FILING DATE
	6,306,694 B1	10/23/01	Yamazaki et al	438	151	03/10/00
	US 2002/ 0028543 A1	03/07/02	Yamazaki et al	438	154	10/10/01
	6,420,758 B1	07/16/02	Nakajima	257	350	11/16/99
	US 2002/ 0142554 A1	10/03/02	Nakajima	438	301	05/06/02
	6,531,713 B1	03/11/03	Yamazaki	257	59	03/17/00
	US 2003/ 0062499 A1	04/03/03	Yamazaki	251	200	10/29/02
	6,576,926 B1	06/10/03	Yamazaki et al	257	66	02/22/00
	US 2003/ 0197179 A1	10/23/03	Yamazaki et al	257	59	06/09/03

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	NAME	English Abstract	English Trans.	FILING DATE

OTHER PRIOR ART - NON-PATENT LITERATURE DOCUMENTS  
(Including Author, Title, Date, Pertinent Pages)

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EXAMINER:	DATE CONSIDERED:
<p>*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP form. Draw line through citation if not in conformance and not considered. Include a copy of this form with the next communication to applicant.</p>	